



PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventors: Kenneth C. Johnson et al.

Application No.: 10/621,218

Filed: July 16, 2003

For: METHOD OF MEASURING MESO-
SCALE STRUCTURES ON WAFERS

Confirmation No. 1054

Group Art Unit: 2813

Examiner: Craig A. Thompson


**CHANGE OF ATTORNEY OR AGENT'S
ADDRESS IN APPLICATION
(37 CFR 1.8(a))**

353 Sacramento Street, Suite 2200
San Francisco, CA 94111
(415) 772-4900

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents, P.O.
Box 1450 Alexandria, VA 22313-1450 on August 17, 2004.
STALLMAN & POLLOCK LLP

Dated: 08/17/04 By: 
Tanisha Lawrence-Caceres

Sir:

Please send all correspondence for this application to:

STALLMAN & POLLOCK LLP
Attn: Michael A. Stallman
353 Sacramento Street, Suite 2200
San Francisco, CA 94111
Customer No.: 28584


Please direct all telephone calls to:

Michael A. Stallman
Telephone: (415) 772-4900
Facsimile: (415) 398-2890

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: August 17, 2004

By: 
Michael A. Stallman
Reg. No. 29,444
Attorneys for Applicant(s)

Atty Docket No.: TWI-30620